

The Abdus Salam International Centre for Theoretical Physics



2037-20

Introduction to Optofluidics

1 - 5 June 2009

Fabrication of Optofluidic Devices

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Fabrication of Optofluidic Devices

Massimo Tormen

PARTI

Lilit group

Main area of activity:

Nanofabrication technologies
Applications of nanotechnology to biology
Optical manipulation
Photovoltaics
Microfluidics
Plasmonics



Researchers:

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Ph.D. students:

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Lilit Nanotech Facility



Lithography:

- Electron and ion beam dual system
- Soft and Deep X-Ray Lithography
- Nanoimprint & Soft Lithography
- UV (365 nm) mask aligners
- UV (250 nm) flood exposure system
- Spin coaters, hot plates.
- 200 mq cleanroom

Etching:

- Inductive Coupled Plasma (ICP) systems for Si.
- Riective Ion Etcher (RIE)
- Hoods for wet chemical etching

Optical manipulation:

 Different optical tweezers setups for dynamic trapping, force measurements

Deposition:

- HV evaporators
- Sputtering (6" target, 4" wafer)
- PECVD (silicon based materials)
- Electroplating
 - Glove box (SAM's in moisture free atmosphere)

Characterization:

- SEM with microanalisys (EDX)
- Optical microscopes
- Raman microspectrometer
- Semiconductor parameter analyzer
 IV and CV measur., 1 fA , 1 μV res.)
- Sun simulator
- Monocromateor (200-1100 nm)
 - AFM





- Introduction
- Examples of optofluidic microdevices and components
 - Microchannels/waveguides, valves, mixers, dye lasers.
- Lithographic technologies:
 - Soft Lithography
 - Nanoimprinting, Hot embossing
 - UV, EBL, FIB, XRL, hybrid approaches.
- Examples
- Conclusions

Example of "optofluidics": Parabolic mercury mirror

Rotating liquid mirror telescope

Atomic scale roughness. ©

Perfect parabolic shape obtained with the laws of nature. ©

Can be actuated (vary the focal length). ③

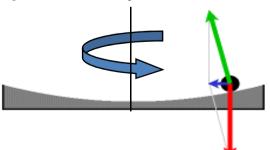
Low cost telescope (500 k\$ against 25 M\$). ⓒ

The mirror can only point straight up. ⊗



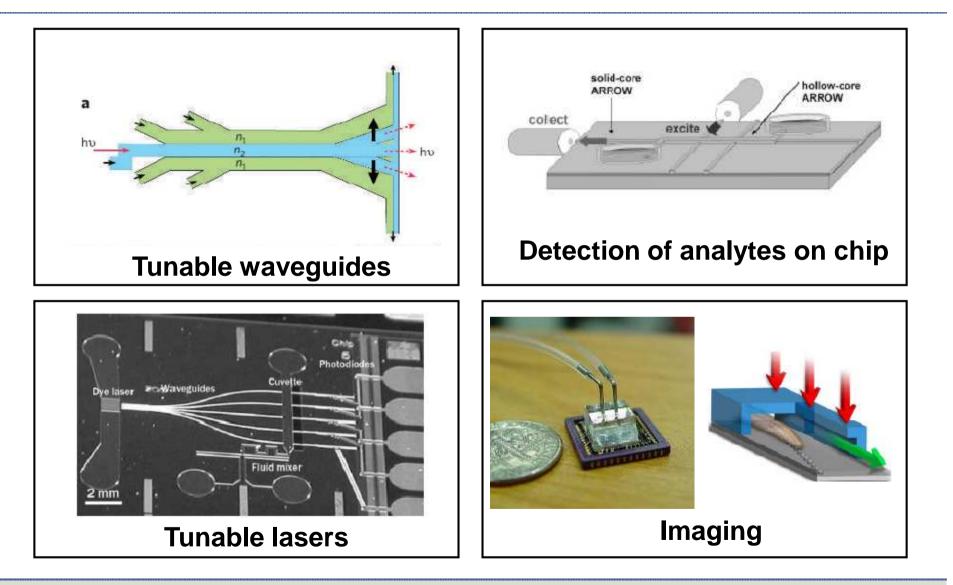
advanced technology and nanoscience

Large Zenith Telescope near Vancouver, Canada. It is a 6-meter telescope with a surface of liquid mercury





Optofluidics in microsystems





Lab-on-a-Chip.

Objectives:

- Replace an entire chemical/biological laboratory
- High level of integration, by miniaturization
- Perform a large number of experiments in parallel. Explore space of parameters combinatorially (Multiplexing).
- Reduce: time, space, material, cost.
- Increase: automation, speed, reliability.
- Portable, simple to use, disposable devices.

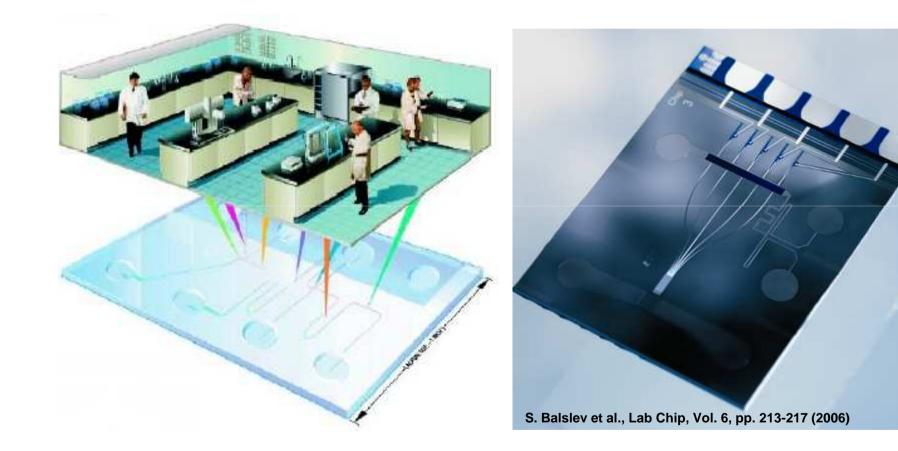


Lab-on-a-Chip.

Functionalities:

- •Sample manipulation (cells, chemicals, biochemicals, liquids)
- •Set conditions (temperatures, Ph, relative concentration of reagents in reaction chambers)
- •Act (cultivate and sort cells, purify molecules, proteins, nucleic acids, amplify DNA, RNA by PCR).
- •Analyse (detect chemicals, measure concentrations, identify type of cells).

Lab-on-a-Chip is based on Microfluidics



Courtesy: Anders Kristensen DTU Nanotech, Technical University of Denmark



Addition of optical functionalities to a microfluidic Chip

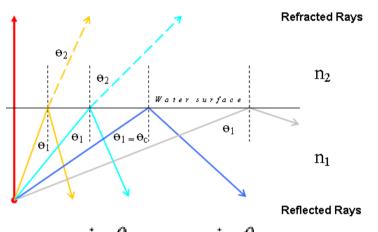
- Waveguides
- Coherent light sources (dye lasers)
- Optical switches actuated by fluids
- Optical manipulation inside liquids
- Reconfigurable optics (tunable lenses)
- Integrated optical detection:
 - Absorption
 - Fluorescence
 - Surface Plasmon Resonance (SPR)
 - Raman



- Waveguides
- Microfluidic lenses
- Mixers
- Valves
- Microfluidic dye laser

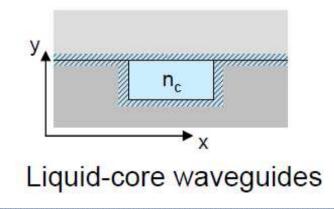


Liquid-core Solid-cladding waveguides



 $n_1 \sin \theta_1 = n_2 \sin \theta_2$

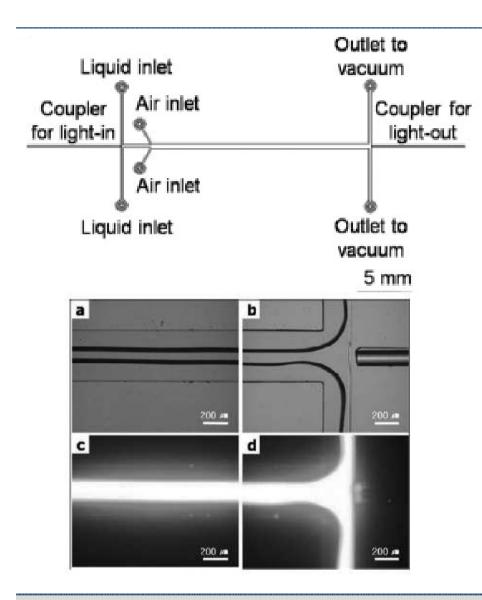
Total Internal Reflection (TIR)



Material	Refractive index
Air	1
Water	1.33
2-Propanol	1.375
Hexane	1.49
CaCl ₂ in w. 5 M	1.44
Teflon AF	1.29
PDMS	1.40
PMMA	1.49
PC	1.58
SU-8	1.59
SiO ₂	1.46
SiN	2.05
Si	3.5

Waveguiding by TIR requires liquid core of higher refractive index (RI) than cladding (= microfluidic channel walls). However, RI of liquids are typically smaller than for polymers and solids.

L² or Liquid-core Air-cladding waveguides



Large structures (I,h,w >>10 µm)

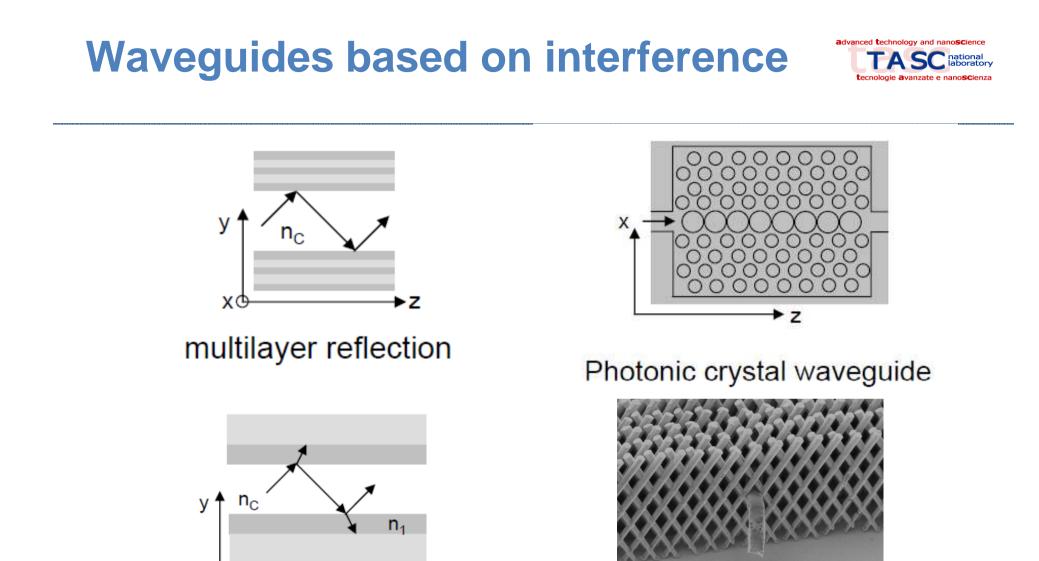
•Fabrication by UV photolithography on photoresists + <u>Soft Lithography</u> for the microfluidic channels.

•<u>PDMS elastomers</u> (RI=1.406) for microchannels, Ethylene Glycol (1.432) as core, air cladding.

•PDMS and glass treated with oxygen plasma before <u>bonding</u>.

•<u>Surface treatment</u> of the inner channel surface to prevent the complete wetting by EG. Use of fuorinated trichlorosilanes on PDMS.

J.-M. Lim Lab Chip, 8, 1580 (2008).



ARROW waveguides

►Z

XQ

F. Romanato et al. 3D PC with embedded waveguide

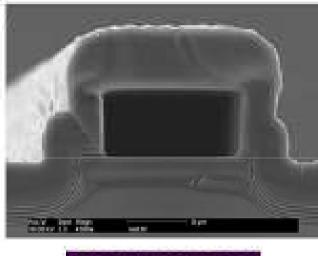
H. Schmidt & A. R. Hawkins Microfluid Nanofluid (2008)

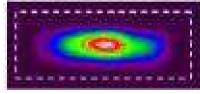
1.0 µm





Planar optofluidic chip for single particle detection, manipulation, and analysis





collect excite

Liquid-core optical waveguides guide both light and fluids in the same volume.

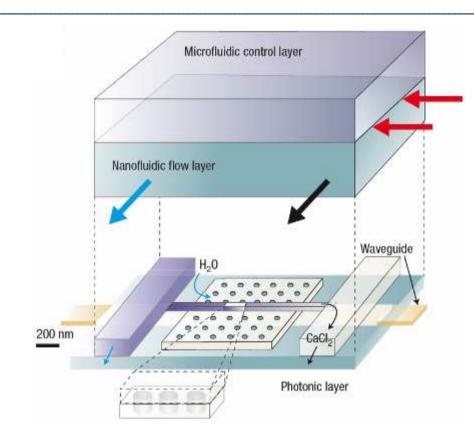
Antiresonant Reflecting Optical Waveguides (ARROW)

H.Schmidt & A. R. HawkinsMicrofluid Nanofluid (2008)

D. Yin et al., Lab Chip, 2007, 7, 1171

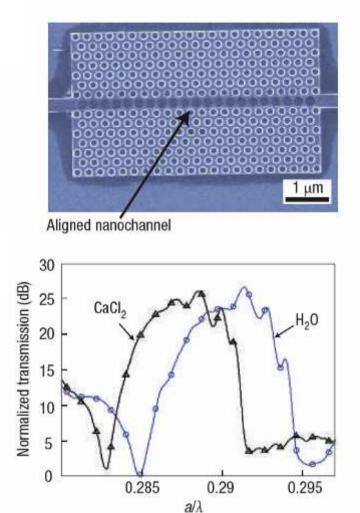


Photonic-crystal based waveguides



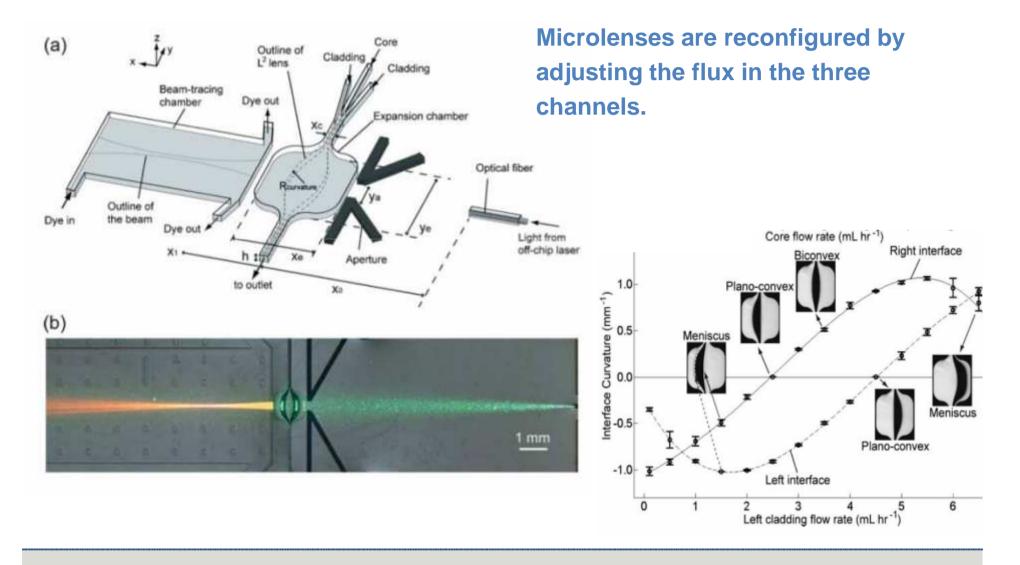
•Photonic crystal controlled by the filling of voids with different liquids.

•Tuning the wavelength dependent attenuation of a waveguide.



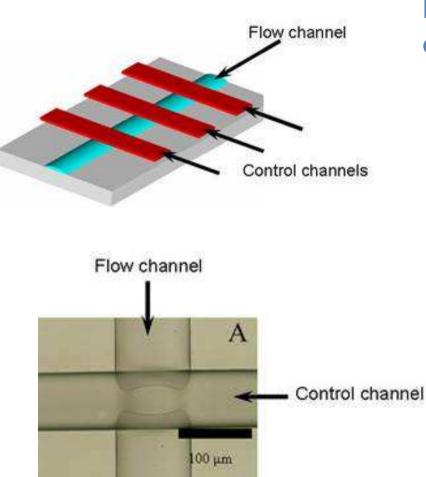


Tunable microlenses (in plane)

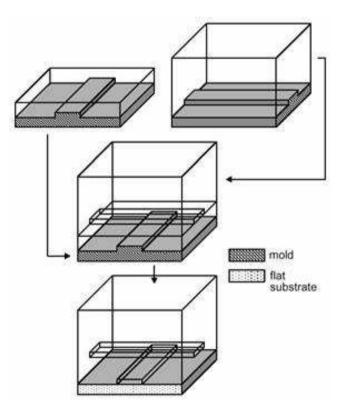


Microfluidic valves





Fabrication by casting liquid precursor of elastomers and thermal curing.

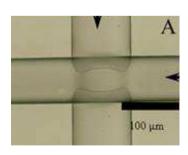


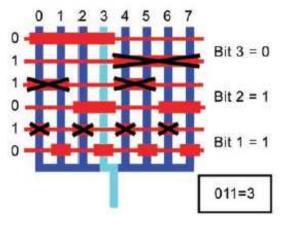
Source: Stanford Microfluidics Foundry http://thebigone.stanford.edu/foundry/technology/valve.html

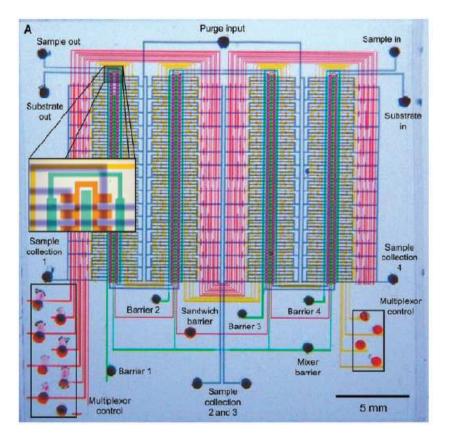


Microfluidics Large Scale Integration

- Controlling 2^N fluidic channels with N input valves (multiplexing). Binary logic.
- Microfluidic channels and control layer made in transparen elastomer (PDMS).
- Microfluidic valves actuated by air pressure (20-50 kPa).

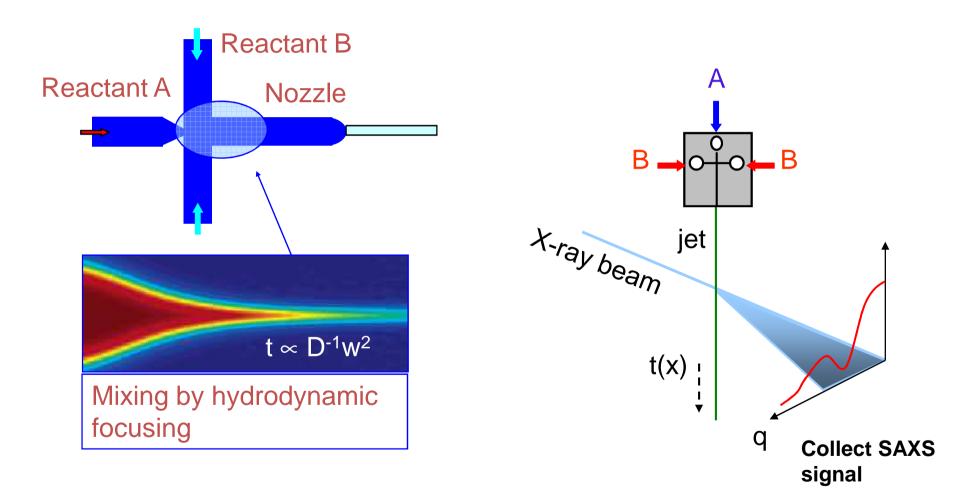






Thorsen *et al.,* Science **298**, 580, (2002) Melin *et al.* Annu. Rev. Biophys. Biomol. Struct. **36**, 213 **(**2007).

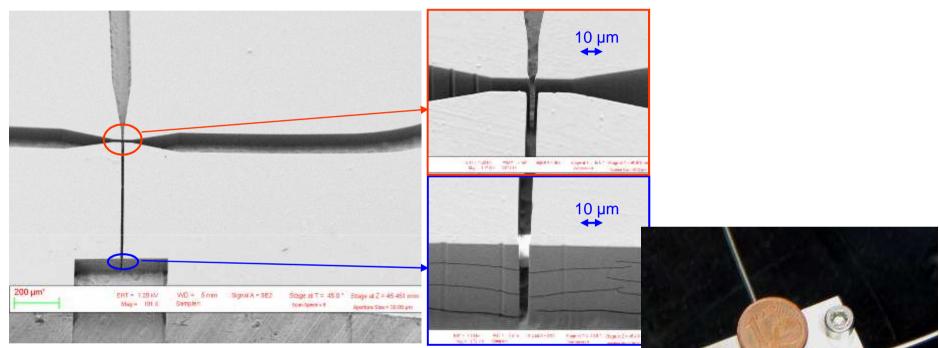




B. Marmiroli, G. Grenci et al. Lab Chip, 2009, DOI: 10.1039/b904296b



Microfluidic mixer

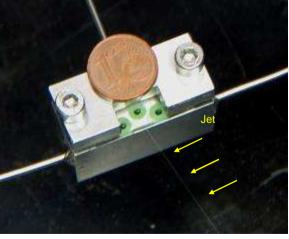


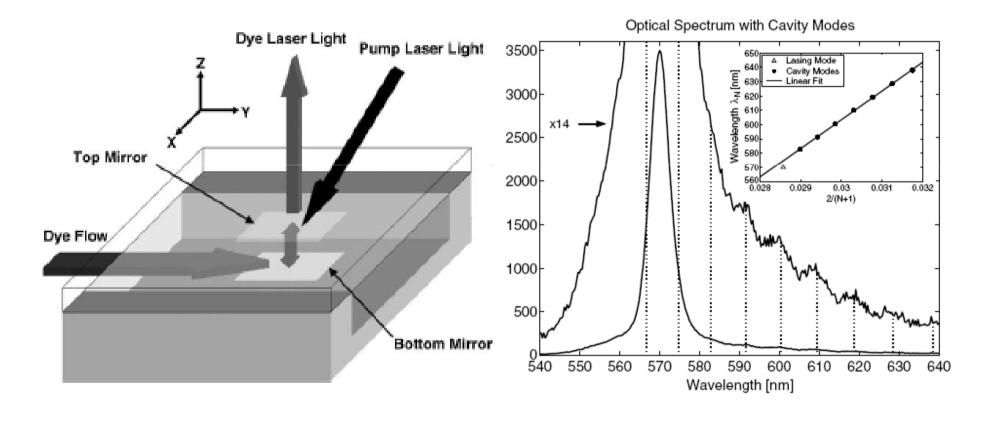
Device in PMMA:

- 60 µm deep channels
- inlet nozzle 5 µm wide
- outlet nozzle 8 µm wide









B. Helbo et al., IEEE MEMS 2003, J. Micromech. Microeng., Vol. 13, 307 (2003) DTU Nanotech, Technical University of Denmark

DTU

Optofluidic DFB Laser (2005)

